



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 1256  
Yoshihiro GUNJI et al. : Docket No. 2001-1075A  
Serial No. 09/917,732 : Group Art Unit 1763  
Filed July 31, 2001 : Examiner Sylvia MacArthur

SUBSTRATE HOLDING APPARATUS AND  
SUBSTRATE POLISHING APPARATUS

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**REQUEST TO TREAT AUTHORIZATION TO CHARGE  
ALL REQUIRED FEES AS AN EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants in the above-referenced U.S. patent application filed a response on April 22, 2004. This was in response to a first Office Action carrying a due date of March 22, 2004. Accordingly, a one month extension of time was required.

However, Applicants undersigned representative did not include a formal petition for the one month extension of time. The response filed April 22, 2004 did, however, include an authorization to charge any necessary fees for the paper. Accordingly, under the practice as set forth in 37 CFR 1.136(a)(3), second sentence, and as discussed in MPEP §710.02(e), the Office is respectfully

requested to treat the authorization to charge required fees as the petition for the extension of time, and to charge the fee for the petition for extension of time to Applicants' undersigned representative's deposit account, i.e. 23-0975.

Respectfully submitted,

Yoshihiro GUNJI et al.

By: 

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April 23, 2004

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975